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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.		
10/730,101	01 12/09/2003 Yoshinori Shizuno		OKI.630	2667		
20987 7	7590 04/06/2005		EXAMINER			
VOLENTINE FRANCOS, & WHITT PLLC			WARREN, MATTHEW E			
ONE FREEDOM SQUARE 11951 FREEDOM DRIVE SUITE 1260 RESTON, VA 20190			ART UNIT	PAPER NUMBER		
			2815 DATE MAILED: 04/06/2005			

Please find below and/or attached an Office communication concerning this application or proceeding.

	A	NI -	I Auglionation			_			
	Applicati	on No.	Applicant(s)						
	10/730,1	01	SHIZUNO, YOSHII	NORI	(One				
Office Action Summary	Examine	7	Art Unit			_			
	Matthew I	E. Warren	2815						
The MAILING DATE of this communication Period for Reply	The MAILING DATE of this communication appears on the cover sheet with the correspondence address								
A SHORTENED STATUTORY PERIOD FOR RETHE MAILING DATE OF THIS COMMUNICATION - Extensions of time may be available under the provisions of 37 CF after SIX (6) MONTHS from the mailing date of this communication - If the period for reply specified above is less than thirty (30) days, and If NO period for reply is specified above, the maximum statutory period for reply within the set or extended period for reply will, by so any reply received by the Office later than three months after the meanned patent term adjustment. See 37 CFR 1.704(b).	ON. R 1.136(a). In no ev n. a reply within the stateriod will apply and w statute, cause the app	ent, however, may a reply be ti utory minimum of thirty (30) da ill expire SIX (6) MONTHS fror dication to become ABANDON	mely filed ys will be considered timely n the mailing date of this co ED (35 U.S.C. § 133).	mmunic	eation.				
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,	This action is r								
	Since this application is in condition for allowance except for formal matters, prosecution as to the ments is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.								
Disposition of Claims									
4) □ Claim(s) 1-12 is/are pending in the application. 4a) Of the above claim(s) is/are withdrawn from consideration. 5) □ Claim(s) is/are allowed. 6) □ Claim(s) 1-12 is/are rejected. 7) □ Claim(s) is/are objected to. 8) □ Claim(s) are subject to restriction and/or election requirement.									
Application Papers		-							
9) ☐ The specification is objected to by the Exar 10) ☑ The drawing(s) filed on 29 December 2004 Applicant may not request that any objection to Replacement drawing sheet(s) including the co 11) ☐ The oath or declaration is objected to by the	is/are: a) a a the drawing(s) orrection is required.	be held in abeyance. So red if the drawing(s) is o	ee 37 CFR 1.85(a). bjected to. See 37 CF	R 1.12					
Priority under 35 U.S.C. § 119									
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 									
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SI Paper No(s)/Mail Date		4) Interview Summar Paper No(s)/Mail [5) Notice of Informal 6) Other:	Date)-152)					

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DETAILED ACTION

This Office Action is in response to the Amendment filed on December 29, 2004.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims1-12 are rejected under 35 U.S.C. 103(a) as being unpatentable over .

Kikuchi (US Pub. 2002/0005568 A1) in view of Satoh et al. (US Pub. 2002/0025655 A1).

In re claims 1, 5, and 9, Kikuchi shows (figs 1 and 2) a substrate (110) which has a main surface formed with a circuit element; an electrode pad (120) formed over the main surface of the substrate and is electrically connected to the circuit element; a wiring (160) which is formed over the main surface and which is electrically connected to the electrode pad; a sealing resin (180) which covers the main surface of the substrate and the wiring; and an external terminal (190) which is electrically connected to the wiring and which is exposed from a surface of the sealing resin. The electrode pad is formed next to the edge of the sealing resin. Kikuchi shows all of the elements of the claims except the edge of the sealing resin formed inside an edge of the substrate and the edge of the substrate and sealing resin located along a substrate grid line.

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Satoh et al. shows (fig. 1) a semiconductor device comprising a sealing resin (5) which covers the main surface of the substrate and the wiring; wherein an edge of the sealing resin is formed inside an edge 1(1) of the substrate and along a grid line (or scribe line...[0059]). By forming the edge in this manner, semiconductor packages are not damaged during the dicing process and reliable packages are produced [0072]. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the sealing edge of Kikuchi by forming the sealing side surface inside of a side surface of the substrate as taught by Satoh so that reliable semiconductor packages are formed without being damaged during the dicing process.

In re claims 4, 8, and 12, Satoh discloses [0061] that the substrate is a silicon substrate.

In re claims 2, 6, and 10, none of the references specifically disclose the limitations of the claims, however, such limitations are "Product by Process" claim limitations. A "product by process" claim limitation is directed to the product per se, no matter how actually made, In re Hirao, 190 USPQ 15 at 17(footnote 3). See also in re Brown, 173 USPQ 685: In re Luck, 177 USPQ 523; In re Fessmann, 180 USPQ 324: In re Avery, 186 USPQ 116 in re Wertheim, 191 USPQ 90 (209 USPQ 254 does not deal with this issue); and In re Marosi et al, 218 USPQ 289 final product per se which must be determined in a "product by, all of" claim, and not the patentability of the process, and that an old or obvious product, whether claimed in "product by process" claims or not. Note that Applicant has the burden of proof in such cases, as the above case law makes clear.

"Even though product-by- process claims are limited by and defined by the process, determination of patentability is based upon the product itself. The patentability of a product does not depend on its method of production. If the product in product-by-process claim is the same as or obvious from a product of the prior art, the claim is unpatentable even though the prior product is made by a different process." In re Thorpe, 227 USPQ 964, 966 (Fed. Cir. 1985)(citations omitted).

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In re claims 3, 7, and 11, Satoh dose not specifically show the seal layer positioned inside of the side surface within the desired range however, it would have been obvious to one of ordinary skill in the art to position the seal layer inside the side surface within the desired range, since it has been held that where the general conditions of a claim are disclosed in the prior art, discovering the optimum or workable ranges involves only routine skill in the art. *In re Aller, 105 USPQ 233.* Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the seal layer of Satoh by forming the seal layer inside of the side surface of a substrate in under 100 microns to form a package fulfilling a specific size requirement because Aller teaches that such a modification only involves routine skill in the art.

Response to Arguments

Applicant's arguments with respect to claims 1-12 have been considered but are most in view of the new ground(s) of rejection.

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Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Matthew E. Warren whose telephone number is (571) 272-1737. The examiner can normally be reached on Mon-Thur and alternating Fri 9:00-5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tom Thomas can be reached on (571) 272-1664. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

MEW

March 17, 2005

(0m)

TOM THOMAS
SUPERVISORY PATENT EXAMINER